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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :
Hitomi SAKURAI :
Serial No. 10/616,732 : Group Art Unit: 2812
Filed: July 10, 2003 : Examiner: Olivia T. Luk
For: METHOD FOR MANUFACTURING :
A SEMICONDUCTOR DEVICE :
(As Amended) : Docket No. S004-5072

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MS NON-FEE AMENDMENT
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

RESPONSE

S I R:

In response to the Office Action dated December 6, 2004, applicant amends his application as follows:

ADDITIONAL FEES:

No additional fees are believed required in connection with this response; however, should it be determined that a fee is due, authorization is hereby given to charge any such fee to our Deposit Account 01-0268.

MAILING CERTIFICATE ON PAGE 25

IN THE TITLE:

The Title of the invention has been amended as follows:

**MANUFACTURING METHOD FOR MANUFACTURING A
SEMICONDUCTOR DEVICE**